

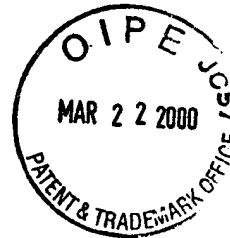
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al Art Unit : 1753  
Serial No.: 08/907,182 Examiner : A. Diamond  
Filed : August 6, 1997  
Title : THIN-FILM PHOTOELECTRIC CONVERSION DEVICE AND A  
METHOD OF MANUFACTURING THE SAME

BOX AF

Assistant Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT



#  
11/C  
(W.M.)  
3/24/00

In response to the Office Action mailed December 16, 1999,  
kindly amend the above-referenced application as follows:

In the Claims:

Please cancel claims 31 and 56.

Please amend the following claims:

26. (Amended) A method of manufacturing a device  
comprising:

providing a semiconductor film on an insulating surface  
providing the semiconductor film with a catalyst [metal  
containing] metal-containing material;

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